

Temperature dependence of the frequency response of InGaAsP/InP semiconductor laser : Theoretical approach

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Abstract

This paper investigates theoretically the temperature effect on the frequency response of a semiconductor laser . The theoretical results are compared to the published ones where a fair agreement is noticed in particular of the 3 dB frequency .

I - Introduction

The high power efficiency and high speed capabilities of III-V semiconductor lasers have made signal transmission in both digital and analog optical fiber communication systems a reality [1] .The development of silica optical fibers, that have lowest transmission loss and lowest dispersion in the 1 - 1.7 μm , region has stimulated more interest in the quaternary In Ga-As P materials because the resulting band gap-wavelength covers the above spectral region [2] .The particular composition $\text{In}_{0.72}\text{Ga}_{0.28}\text{As}_{0.6}\text{P}_{0.4}$ of the active layer which lattice matches In P is chosen because its band gap ($E_g = 0.96$ eV , $\lambda = 1.3$ μm) is at region of low loss and minimum dispersion in optical fibers [3] .

In the present work , the temperature dependence of the frequency response of semiconductor lasers is theoretically investigated .

II - Small-Signal Modulation of a Semiconductor Laser

The frequency response of a semiconductor laser can be predicted by appropriate rate equations describing the electron N and the photon S densities in the active region of the laser [4] :

$$\frac{dN}{dt} = \frac{I}{qV} - \frac{g_0}{1 + \epsilon S} (N - N_T) S - \frac{N}{\tau_n} \quad (1)$$

where I is the injected current , q is the electronic charge , V is the active region volume , g_0 is the unsaturated gain , ϵ is the gain compression parameter , N_T is the electron density at transparency , and τ_n is the electron lifetime ,

and :

$$\frac{dS}{dt} = \frac{g_0}{1 + \epsilon S} \Gamma (N - N_T) S - \frac{S}{\tau_p} + \beta \Gamma \frac{N}{\tau_n} \quad (2)$$

where Γ is the confinement factor , β is the spontaneous emission

- constant, and τ_D is the photon lifetime given by [5]:

$$\tau_D = \frac{n_r}{c} \cdot \frac{1}{\alpha_{tot}} \quad (3)$$

where n_r is the refractive index in the active region, c is the light speed in free-space, and α_{tot} is the total losses which can be obtained through [6]:

$$\alpha_{tot} = \alpha_i + \frac{1}{L} \ln\left(\frac{1}{r}\right) \quad (4)$$

with α_i the internal optical losses, L the cavity length, and r the mirror reflectivity.

The use of small signal analysis in eqs.(1) and (2) yields the laser frequency response without parasitic effect (intrinsic effect) as [7]:

$$\frac{s}{1} = \frac{A}{\omega^2 + jB\omega + C} \quad (5)$$

where A , B , and C are real quantities depending on the previously mentioned factors. The normalized magnitude of the frequency response, in dB, at any frequency referred to the dc value is:

$$\frac{\left| \frac{s}{1} \right|_f}{\left| \frac{s}{1} \right|_{f=0}} = 20 \log \frac{|C|}{\sqrt{(\omega^2 + C)^2 + (B\omega)^2}} \quad (6)$$

III - Temperature Dependence of the Affecting Parameters

Many factors influence the values of both the quantum efficiency η and the electron lifetime τ_n . This clearly appears in the Auger recombination process [8], in which η and τ_n are, respectively, given by:

$$\eta = \frac{1}{1 + N(C_a/B_r)} \quad (7)$$

and

$$\tau_n = \frac{1}{B_r N + C_a N^2} \quad (8)$$

where C_a is the Auger coefficient and B_r is the radiative recombination rate; both are temperature dependent.

A general form for the Auger coefficient, as a function of temperature T ($^{\circ}\text{C}$), can be obtained by using a computer program curve fitting for the data published in Ref.[8]. The best curve fitting yields the form:

$$C_a = (5.027 + 0.0278 T + 0.0002 T^2 - 8.122 \times 10^{-7} T^3 - 1.282 \times 10^{-9} T^4 + 3.505 \times 10^{-11} T^5 - 3.68 \times 10^{-13} T^6) \times 10^{-29} \text{ cm}^6 \cdot \text{s}^{-1} \quad (9)$$

Similarly, and based on the data given in Ref.[9], the radiative recombination rate B_r is obtained in the form:

$$B_r(T) = \left(\frac{300}{T + 273} \right)^{0.8} \times 10^{-10} \text{ cm}^3 \cdot \text{s}^{-1} \quad (10)$$

The spontaneous emission factor, β , which appears in a given mode of an injection laser is given by [10]:

$$\beta = \frac{\eta_{th} g_0}{V B_r (N_{th} - N_T)} \quad (11)$$

where η_{th} and N_{th} are, respectively, the efficiency and electron density (concentration) at threshold.

The temperature dependence of all η , τ_n , and β is included through both C_a , eq.(9), and B_r , eq.(10).

Concerning the differential gain g_0 , the transparency N_T , and the threshold electron density N_{th} we introduce two approaches:

Approach I

In this approach, the optical gain g has the form [9]:

$$g = a N - b \quad \text{cm}^{-1}, \quad (12)$$

where N is the electron density, a , and b are temperature dependent constants. Based on the data given in Ref[9], one can express the constants a and b in the forms:

$$a = 1.35 \times 10^{-16} \exp\left(0.584 \left(\frac{298}{T+273} - 1\right)\right) \text{ cm}^2, \quad (13)$$

$$b = 150 \exp\left(0.778 \left(1 - \frac{298}{T+273}\right)\right) \text{ cm}^{-1}. \quad (14)$$

Using eq.(12), one can get:

$$g_0 = \frac{C}{\Delta r} \cdot a \quad \text{cm}^3 \cdot \text{s}^{-1} \quad (15)$$

From definition, the electron density at transparency N_T is the electron concentration at which the gain g is equal to zero, hence, eq.(12) gives:

$$N_T = \frac{b}{a} \quad \text{cm}^{-3} \quad (16)$$

At threshold, the useful optical gain is equal to the total losses, and, after some algebraic manipulation, one can get the threshold electron density, N_{th} , as:

$$N_{th} = N_T + \frac{V \alpha_{tot}}{F g_0} \quad \text{cm}^{-3}, \quad (17)$$

Here, we must keep in mind that the temperature affects the values of g_0 , N_T , and N_{th} through the constants a , eq.(13) and b , eq.(14).

Approach II

In this approach, the optical gain g is expressed under the form [2]:

$$g = \alpha_1 N^2 + \beta_1 N - \gamma_1 \quad (18)$$

where α_1 , β_1 , and γ_1 are temperature dependent constants that when obtained [11], they give the differential gain, g_0 , and the electron density at transparency, N_T , as functions of temperature T ($^{\circ}\text{C}$), as:

$$g_0 = (8.935 - 0.065 T + 6.4355 \times 10^{-5} T^2 + 1.031 \times 10^{-7} T^3 + 1.060 \times 10^{-9} T^4) \times 10^{-6} \quad \text{cm}^3 \cdot \text{s} \quad (19)$$

and:

$$N_T = (1.474 + 0.002 T + 8.436 \times 10^{-6} T^2 + 5.974 \times 10^{-8} T^3 + 1.749 \times 10^{-10} T^4) \times 10^{16} \quad \text{cm}^{-3} \quad (20)$$

Again , using eq.(17) , the threshold electron density N_{th} can be expressed as a function of temperature T (°C) .

IV- Results and Discussion

The device studied in the present work is a 1.3 μ m InGaAsP vapor-phase-regrown buried heterostructure laser. A schematic diagram of our version , of a constricted-mesa laser , is shown in Fig. 1 . To calculate the total frequency response , we adjust the value of the compression factor ϵ to follow the experimental data.

We have applied the previous procedure at T = 20 °C and -60 °C based on the data given in Refs.[6,12] , respectively . The obtained results are displayed in Figs. 2 and 3.

Figures 2 and 3 shows the obtained intrinsic frequency response in approaches I and II together with the measured ones , respectively , at T = 20 °C [6] and at T = -60 °C [12] .

One can generalize the above procedure for any temperature between -60 °C and 20 °C for output power from 10 to 16 mw assuming that the compression factor ϵ varies linearly with both temperature T and output power P . Hence , one can write a general form for ϵ as :

For approach I :

$$\epsilon(T, P) = 1.8489 \times 10^{-17} - 8.202 \times 10^{-16} P - 6.01 \times 10^{-19} T + 4.3421 \times 10^{-17} P T \quad (21)$$

and for approach II :

$$\epsilon(T, P) = 9.799 \times 10^{-17} - 5.254 \times 10^{-15} P - 6.005 \times 10^{-19} T + 4.342 \times 10^{-17} P T \quad (22)$$

V - Conclusion

A theoretical model for the temperature dependence of the parameters affecting the frequency response of a semiconductor laser is introduced. Using this model , the frequency response for a semiconductor laser can be predicted at any temperature in the range -60 °C to 20 ° , and at an output power that varies from 10 to 16 mw.

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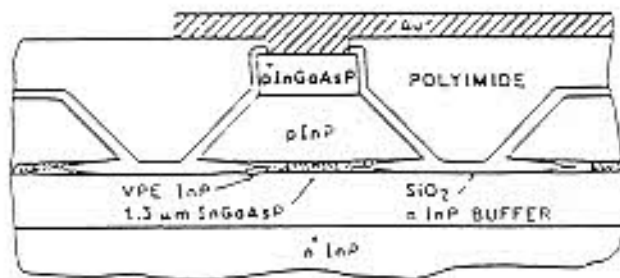


Fig.1 Schematic diagram of a constricted-mesa laser

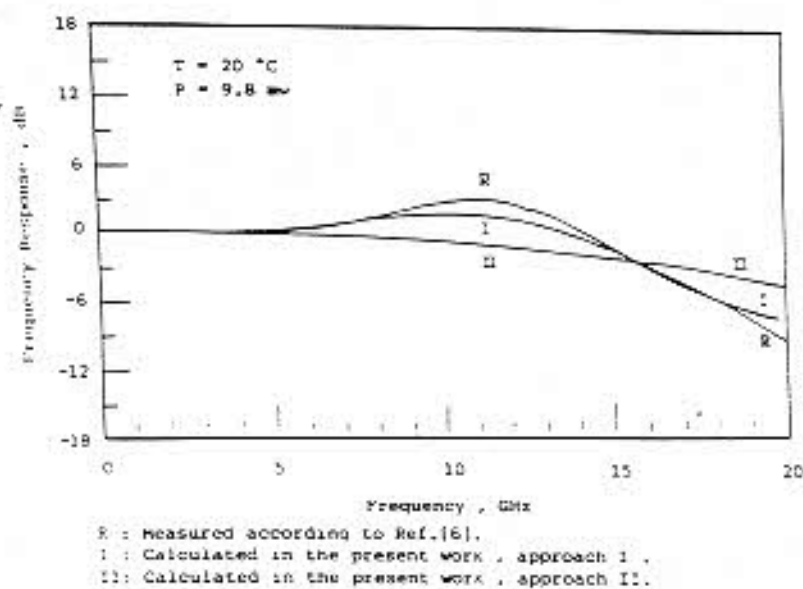


Fig.2 The laser frequency response

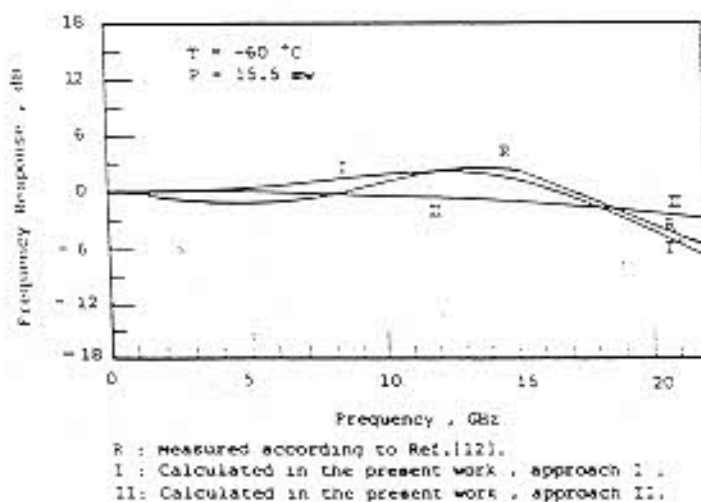


Fig.3 The laser frequency response